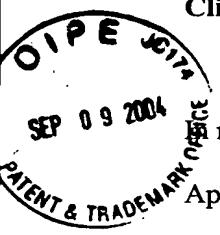


Attorney Docket No. 071469-0307692
Client Reference: RAJ-024

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: HONGYU YUE, WESLEY NATZLE

Application No.:

Confirmation

No:

Filed: March 30, 2004

Group No.:

Examiner

For: METHOD AND SYSTEM FOR PERFORMING A CHEMICAL OXIDE REMOVAL
PROCESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: HONGYU YUE
Citizenship: PEOPLES' REPUBLIC OF CHINA
Residence: Plano, TX 75025

Second applicant: WESLEY NATZLE
Citizenship: USA
Residence: New Paltz, NY 12561

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: METHOD AND SYSTEM FOR PERFORMING A CHEMICAL OXIDE
REMOVAL PROCESS

Docket number assigned to this application: 071469-0307692

Suggested Classification: Class:
Subclass:
Technology Center to which subject matter is assigned:

Total number of drawing sheets: 20

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Assignee information

The assignee(s) of this application is/are:

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Extent of interest of assignee in application: 50%

International Business Machines Corporation
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Extent of interest of assignee in application: 50%

Date: September 9, 2004

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